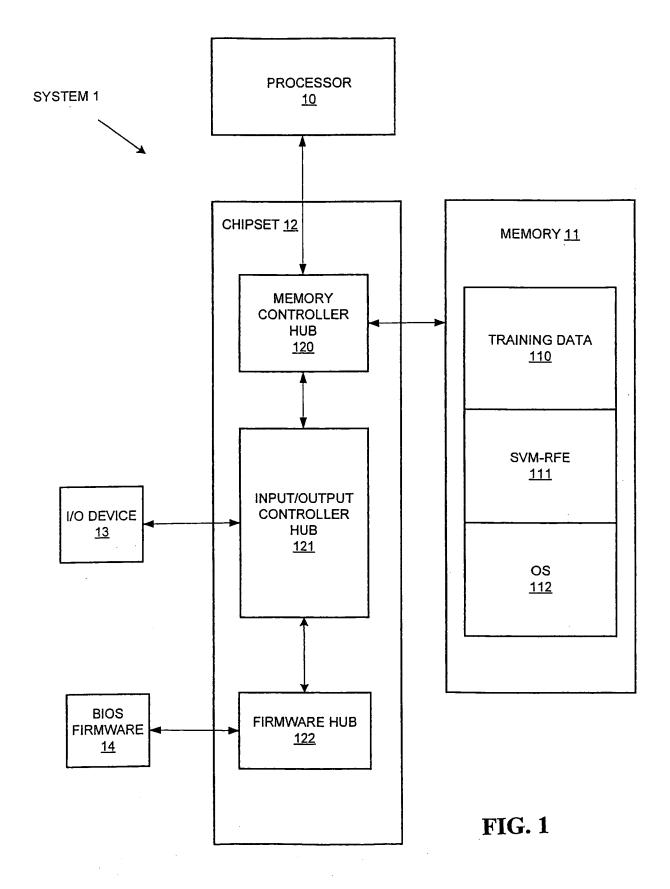
Gas Phase Chemical Sensor Based on Film Bulk Resonators (FBAR) Inventor: Ma et al Filing Date: July 20, 2006

Attorney Docket No.: 42P21656

Express Mail No.: EV777143089US



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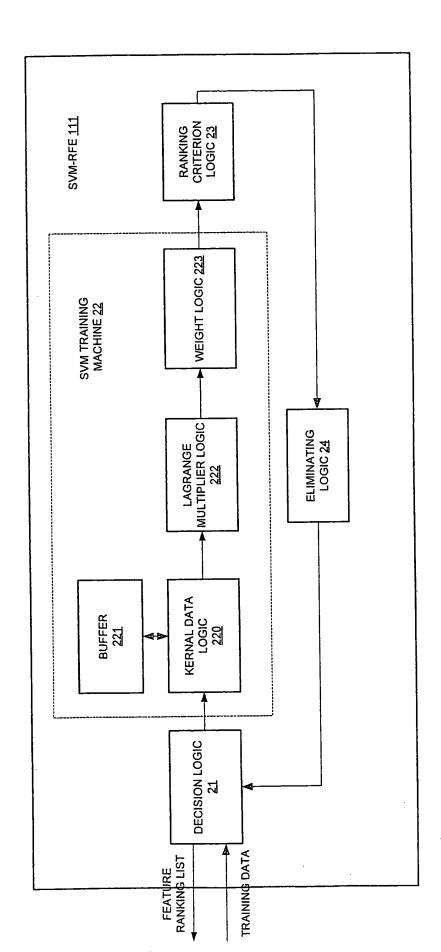
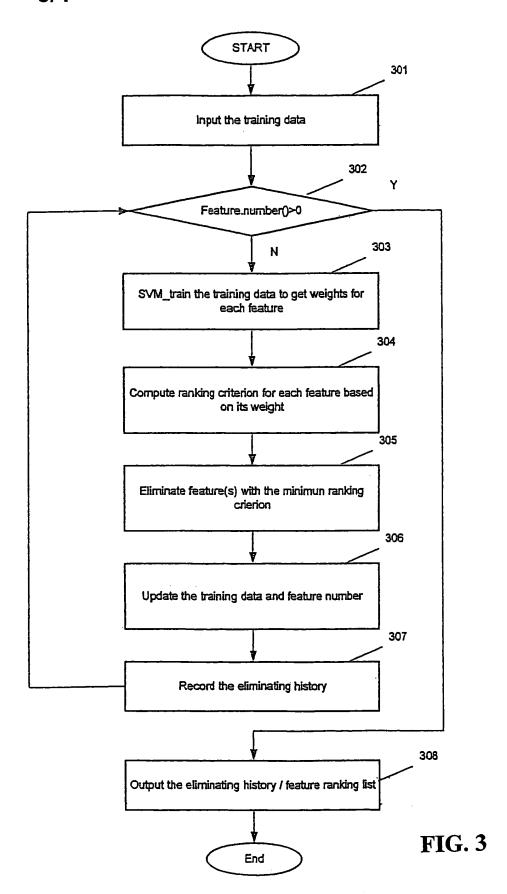


FIG. 2

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